

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination 10/586,979 IVERSEN ET AL.	
		Examiner	Art Unit Chun-Cheng Wang	1796 Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0033269 A1	02-2004	Hei et al.	424/616
	B	US-			
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	D	US-			
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	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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